



#12/Ext. of Time (2)
PATENT APPLICATION
C. Will

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date June 14, 2002

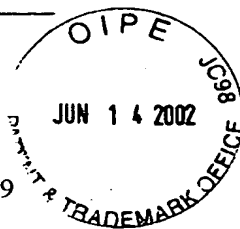
In re the Application of

Shunichi SEKI, et al.

Application No.: 09/423,969

Filed: November 17, 1999

For: THIN FILM PATTERNING SUBSTRATE
AND SURFACE TREATMENT THEREFOR



Group Art Unit: 2814

Examiner: A. Mai

Docket No.: 104741

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JUN 24 2002
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**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired April 14, 2002, an extension of time for a period of 2 month is hereby requested. Attached hereto is our Check No. 131632 in the amount of \$400.00 in payment for:

_____	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
<u>X</u>	Extension fee for response within second month pursuant to §1.136(a) (\$400.00)
_____	Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

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400.00 OP

Respectfully submitted,

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DEPOSIT ACCOUNT USE
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